

2017 Editorial Calendar

(Editorial close date: 4/21)	July • August	* indicates show distribution
OSATs: Challenges for revenue growth High-density advanced packaging solutions for toda	ay's OSATs & foundries	• ICEPT 2017 Harbin, China (Aug 16-19) • BiTS China 2017
Wafer thinning		Shanghai, China (Sept 7) • SEMICON Taiwan *
TSV technologies for next-gen application challenges		Taipei, Taiwan (Sept 13-15) • SMTA International *
Die attach solutions		Rosemont, IL (Sept 17-21) • European MEMS Summit
Performance and cost for 2.5D packaging		Grenoble, France (Sept 20-22)
3D metrology challenges		
3D capacitors for on-chip integration		
HVM of chip-on-submount		

International directory of IC packaging foundries

Ad Space Close Jun 30 - Ad Materials Close Jul 7

(Editorial close date: 6/9)	September • October	* indicates show distribution
Technology trends in photonics packaging		• IMAPS 2017 * Raleigh, NC (Oct 9-12) • IWLPC-International Wafer-Level Packaging Conference & Exhibition * San Jose, CA (Oct 24-26) • International Test Conference (ITC) Fort Worth, TX (Oct 31- Nov 2) • MEMS Executive Congress Napa Valley, CA (Nov 1-2) • SEMICON Europa Munich, Germany (Nov 14-17)
Lithographic challenges for PLP		
Packaging ICs/sensors for automotive applications		
High-volume via formation in solid-core glass for IC substrates		
Excimer laser ablation for fine RDL routings		
Final test		Wullich, Germany (NOV 14-17)
Packaging SiPs/SiP supply chain		
Interferometry sensors for metrology applications		
Non-destructive 3D X-ray imaging for advanced packaging	failure analysis	

Ad Space Close Sep 9 - Ad Materials Close Sep 16

(Editorial close date: 9/1)	November • December	* indicates show distribution
2.5D & 3D ICs		• 3D ASIP Conference * Burlingame, CA (Dec 5-7) • EPTC 2017 Singapore (Dec 6-9) • SEMICON Japan Tokyo, Japan (Dec 13-15) • SEMI European 3D Summit * Grenoble, France (Jan 22-24, 2018)
Probe technology for advanced 3D chips		
China IC market update		
Packaging challenges for automotive applications		
Optimization of fan-out die placement		
What's now & next in MEMS & Sensors		
TCB – Part 2		
IC cleaning process		

International directory of bonding equipment for 2.5D & 3D assembly

Ad Space Close Nov 4 - Materials Close Nov 11